



Docket No.: S1432-700819

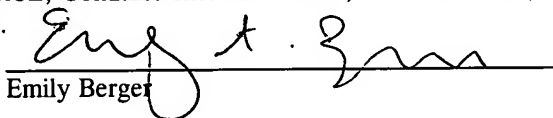
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Yeshwanth Narendar et al.
Serial No: 10/752,434
Confirmation No: 3742
Filed: January 6, 2004
For: HIGH PURITY SILICON CARBIDE ARTICLES AND METHODS

Examiner: Karl E. Group
Art Unit: 1755

CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)

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Emily Berger

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Commissioner for Patents
P.O. Box 1450
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AMENDMENT

Sir:

In response to the final Office Action mailed July 13, 2006, please amend the above-identified application as follows. Changes to the Claims are shown by strike through for deleted matter and underlining for added matter.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 5 of this paper.